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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: Examiner: Arnel C. Lavarias  
MAKOTO OGUSU ET AL. )  
: Group Art Unit: 2872  
Application No.: 10/023,689 )  
: Filed: December 21, 2001 )  
: For: METHOD OF MANUFACTURING )  
DIFFRACTIVE OPTICAL ELEMENT : December 2, 2004

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

A. Introductory Comments

In response to the Office Action dated September 2, 2004, kindly amend the subject application as follows.

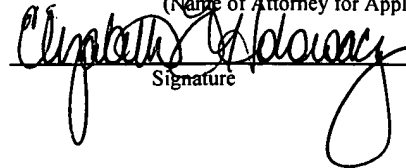
I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

December 2, 2004

(Date of Deposit)

Elizabeth F. Holowacz

(Name of Attorney for Applicants)

  
Signature

December 2, 2004  
Date of Signature